

**Search Notes**

Application/Control No.

10/517,830

Examiner

Rebecca M. Stadler

Applicant(s)/Patent under  
Reexamination

IIJIMA ET AL.

Art Unit

1754

**SEARCHED**

Class	Subclass	Date	Examiner
423	445B	2/22/2006	RMS
977	ALL	2/22/2006	RMS

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
STN search "nanohorn"	2/22/2006	RMS